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QUARTZ GAUGE RESPONSE IN ION RADIATION

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This paper describes recent work to make high quality quartz gauge (temporal and spatial) shock wave measurements in a pulsed ion beam environment. Intense ion beam radiation, nominally 1 MeV protons, was deposited into material samples instrumented with shunted quartz gauges adjacent to the ion deposition zone. Fluence levels were chosen to excite three fundamentally different material response modes (1) strong vapor, (2) combined vapor and melt phase and (3) thermoelastic material response. A unique quartz gauge design was utilized that employed printed circuit board (PCB) technology to facilitate electrical shielding, ruggedness, and fabrication while meeting the essential one dimensional requirements of the characterized Sandia shunted quartz gauge. Shock loading and unloading experiments were conducted to evaluate the piezoelectric response of the coupled quartz gauge/PCB transducer. High fidelity shock wave profiles were recorded at the three ion fluence levels providing dynamic material response data for vapor, melt and solid material phases.

INTRODUCTION

Development of multi-phase material constitutive models requires time resolved physical properties data i.e., stress, impulse, velocity, mass, energy, etc. Intense pulsed radiation sources, such as the GAMBLE II accelerator, located at the U. S. Naval Research Laboratory, can be used to generate material response data in solid, melt and vapor phases, which are required for model development. Due to the 10-60 ns GAMBLE II ion beam pulse duration, 0.5 Ghz transducers and recording systems must be used to acquire high fidelity data. Also, the transducer and signal cable must be configured/shielded to reject electrical noise pickup/generation at accelerator discharge. Unique quartz gauges (designated AWEQG) were used in this program to acquire aluminum material response data for multi-phase states. This paper presents ion beam test results as well as quartz gauge characterization data.

QUARTZ GAUGE DESIGN AND CHARACTERIZATION

The one-dimensional shunted x-cut quartz gauge has been a standard for stress measurement in impact physics work since 1965 when Graham characterized its response to planar shock loading (1). This original work described the shock induced piezoelectric response of a precisely defined quartz disk (designated the Sandia Quartz Gauge (SQG) Figure 1) based on crystallographic orientation, disk dimensions, electrode configuration, guard ring width, etc. Since the original quartz characterization work, other quartz gauge configurations have been utilized in an attempt to improve certain gauge features i.e., increased signal level, longer recording time, improved electrical shielding and ruggedness (2, 3). Each of the changes made to the SQG design produced a deviation in the quartz piezoelectric shock response when compared to the 1965 characterization study, however.

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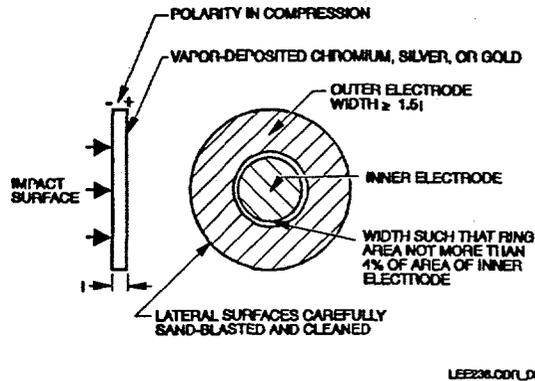
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Two of the most difficult steps in producing a high quality SQG is soldering electrical leads to the thin



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FIGURE 1. Sandia x-cut quartz guard-ring configuration to obtain one-dimensional conditions.

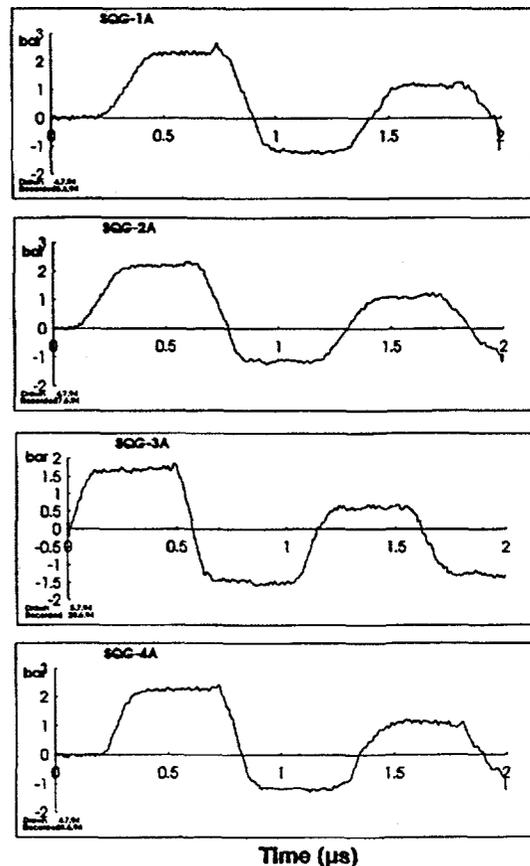
metal electrode and cutting the precise guard ring that separates the active and guard ring areas. For this ion beam application, a different approach (AWEQG) was taken to achieve both of these functions using printed circuit board (PCB) technology, in an attempt to ease fabrication and improve ruggedness. Details of the PCB technique are not presented here (patent pending). All other SQG criteria defined in Ref. 1 were adhered to in the AWEQG.

Shock loading characterization of the AWEQG configuration included gas shock tube testing and flat plate impact testing. Shock tube test results (Figure 2) confirmed overall gauge operation, with recorded gauge outputs agreeing with predicted signal levels based on Ref. 1 SQG characterization. Gauge rise time in the shock tube testing was primarily controlled by the precision of gauge-gas shock front alignment, and does not represent a gauge limitation. Shock tube test data taken before and after shipment from the UK to the US confirmed AWEQG ruggedness.

The shock tube results demonstrated AWEQG response but only at low stress (0.2 MPa). Plate impact experiments were performed to evaluate AWEQG piezoelectric response at 0.5 and 1.0 GPa peak stress and to assess any electrical breakdown problems resulting from use of the PCB technology. Precision impact experiments were conducted using the same Sandia compressed gas gun facility used in Ref. 1. The AWEQG disk was impacted with a

precisely aligned x-cut quartz disk used as a projectile facing, whose velocity at impact was accurately measured to $\pm 0.5\%$.

Table I summarizes AWEQG characterization results for three gas gun shots. Initial current jump and subsequent wave shape were evaluated for (a) long pulse loading at 0.5 and 1.0 GPa (2 experiments) and (b) short pulse loading in Figure 3. The initial current jump and current at complete gauge transit were in close agreement with Ref. 1 data (Table 1). The third experiment was designed to assess the short pulse (pulse duration less than quartz gauge transit time) anomaly in shock loaded quartz (4). The anomaly, resulting from shock induced conductivity in the shocked and then unloaded quartz material, manifests



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FIGURE 2. Representative AWEQG shock tube results (4 gauges).

TABLE 1. AWEQG Gas Gun Experimental Results Summary.

Shot Number	u_p^a	σ^b	k^c	i_t/i_i^d	Tilt e	Configuration f
2611	0.066	1.000	2.18	1.05	134	A
2612	0.0335	0.508	2.09	1.02	62	A
2618	0.0662	1.004	2.18	---	262	B

a. u_p is quartz particle velocity at impact surface taken as one-half the impact velocity (mm/ μ s).
 b. σ (GPa) is impact stress calculated from $(\Delta u_p U_s \rho_o)$ where $U_s=5.72$ mm/ μ s and $\rho_o=2.65$ g/cm³.
 c. k is the current coefficient calculated from $(i_t I)/\sigma A U_s$, where i_i is the initial current jump, I is quartz thickness, A is the active area.
 d. i_i is initial current jump and i_t is current at quartz transit time, with i_t/i_i being a measure of current increase during wave-transit time.
 e. Tilt (micro rad) was calculated using quartz output signal rise time, active area diameter, impact velocity and assuming impact of two perfectly flat plates.
 f. Configuration A was 50.8 diameter by 5.08 mm thick x-cut quartz impactor for long pulse loading and configuration B was 50.8 diameter by 0.635 mm thick x-cut quartz impactor (free rear surface) for short pulse loading.

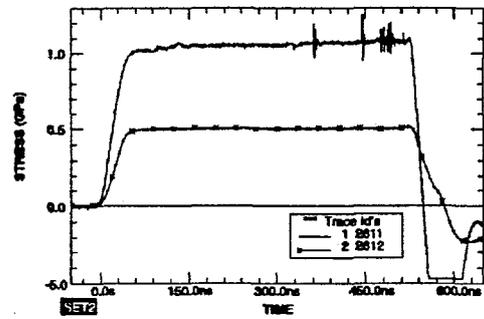
itself as an apparent charge output when there should be no output. Figure 3(b) shows the short pulse experimental data (Shot 2618) with no anomalous current output, i.e., after shock unloading the signal returns to the base line and remains there until complete transit of the gauge. Shot 2618 was designed to have normal response, based on Ref. 4 data, but was located adjacent to the normal/anomalous response boundary at 1.0 GPa. Rise time differences shown in Figure 3 were attributed to non-planarity or tilt at impact, for Shots 2611 and 2612. This high degree of planarity, a unique capability of the gun facility used, was required to define meaningful AWEQG gauge characterization data. The asymmetric rise recorded for Shot 2618 was attributed by deformation in the thin (0.635 mm) quartz impactor due to launch loads.

ION BEAM RESULTS

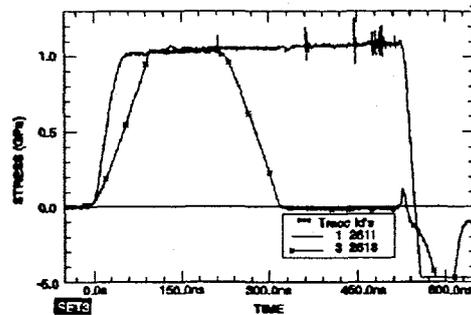
The GAMBLE II accelerator produces nominally 30 kJ of 1 MeV protons, producing a 50 cm diameter beam 1m from the anode. Fluence levels can be varied from 0.1 to 100 cal/cm² and are a function of distance from the anode. Ion pulse width is also dependent on distance from the anode and is between 10 and 60 ns FWHM.

Thirty one samples were irradiated in 10 ion beam

experiments, with high fidelity quartz gauge data being obtained on all samples. Representative



(a)



(b)

FIGURE 3. AWEQG data for (a) 0.5 and 1.0 GPa long pulse loading and (b) 1.0 GPa long and short pulse loading.

AWEQG data are shown in Figure 4 for aluminum samples exposed at 15 and 1.5 cal/cm². Measurable differences in stress and wave shape are apparent for the two fluence levels shown. The 15 cal/cm² exposures produced fast rise shock fronts followed by gradual release representing vapor dominated response. The 1.5 cal/cm² exposures, which produced thermoelastic responses, obviously generated lower peak stress with gradual rise followed by rapid stress release (compared to 15 cal/cm²). Even tensile pulses are evident for the low fluence cases showing the results of elastic wave reflections in the aluminum sample.

All AWEQG gauges were insensitive to accelerator noise generation as evidenced by the signal baseline prior to shock arrival. Also the three records at 1.5 cal/cm², which were from a single ion experiment, show close agreement in basic wave shape.

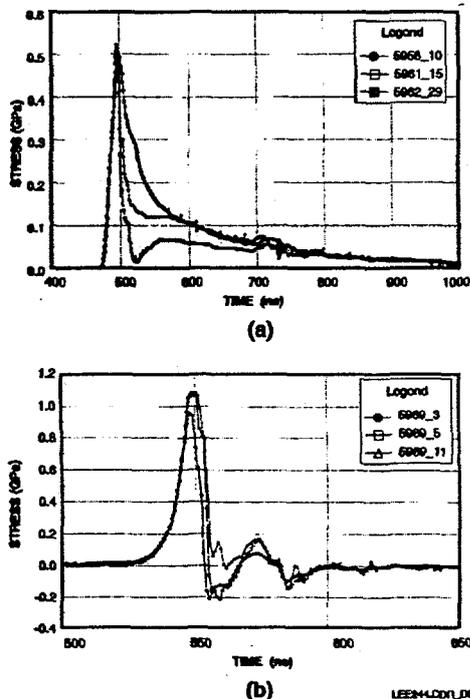


FIGURE 4. Representative AWEQG data from ion beam experiments conducted at (a) 15 cal/cm² and (b) 1.5 cal/cm²

SUMMARY

The AWEQG stress gauges, based on SQG one-dimensional criteria and employing a PCB technique, have shock induced piezoelectric characteristics (loading and unloading) identical to the SQG (Ref 1), up to 1 GPa. Also, the AWEQG did not show the anomolous current response for short pulse loading at 1 GPa. The AWEQG gauge design has excellent ruggedness and minimizes electrical noise pickup in harsh accelerator environments. In the ion beam application the quartz gauges provided high resolution stress-time data that can be used to develop multi-phase material constitutive models spanning the solid through vapor phases.

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